

# p-type TBC cell and module pilot running in Tongwei

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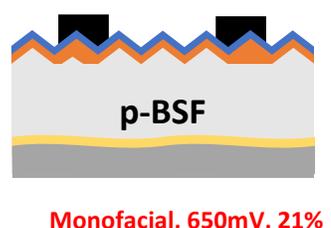
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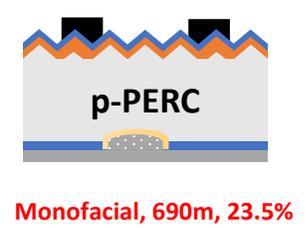
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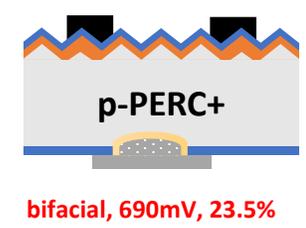
# Evolution of solar cell structure towards Back Contact



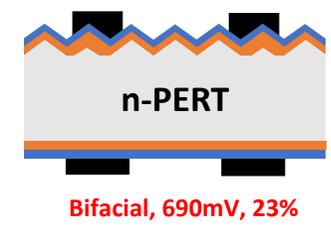
Evolve



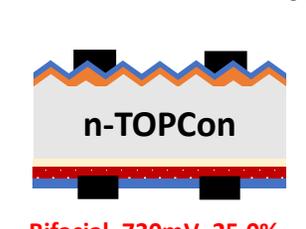
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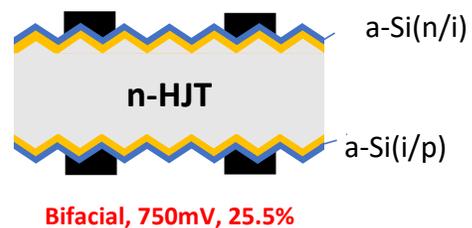
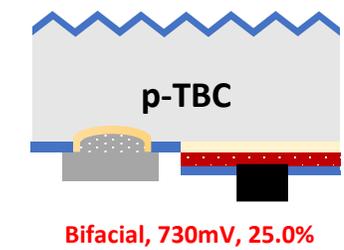
Production Cost?



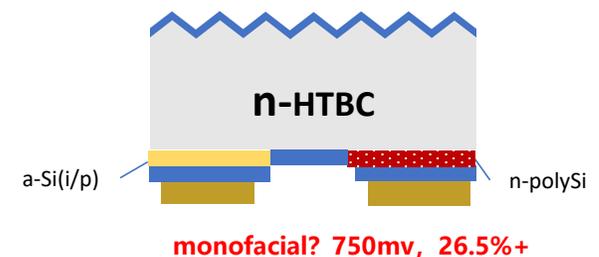
Evolve



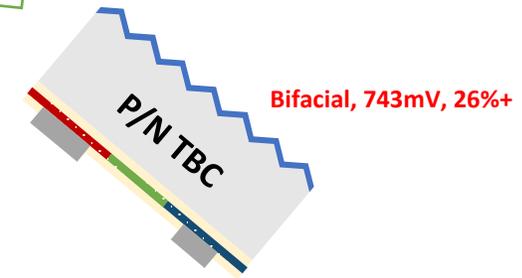
Combine



Combine



Evolve



-  Ag
-  Al
-  Al-BSF
-  Diffusion layer
-  p-Si
-  Dielectric layers(SiNx/AlOx)
-  Dielectric layer(SiOx)
-  n-polySi
-  p-polySi
-  i-polySi
-  Hetero Junction Layer (a-Si/nc-Si)
-  Cu

A Richter et al, Nature Energy, 2021, 6: 429-438.  
R Peibst, et al. Prog Photovolt Res Appl. 2022: 1-14.  
F Haase et al. Sol. Energy Mater. Sol. Cells, 2018, 186: 184-193.

# Comparison of TOPCon and p-TBC to PERC

## Finally, They reached similar Voc and Module Power

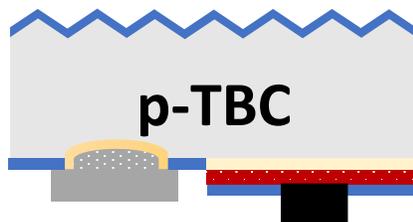
Non-ideal efficiency loss

Extra production cost @M10 size

Module performance



Voc=730mV



Boron Diffusion Junction Recombination

- Ag consumption@100mg M10
- Electricity bill of >1000°C Boron Junction formation

**585W**  
High bifaciality

Contact recombination and resistance of Al-Si BSF

- Ag consumption@80mg M10
- Strict wet chemicals standard
- Packaging papers of cells
- Lower class A yield

**585W**  
Excellent aesthetics  
(Low bifaciality)

# Industrial Processes of TOPCon and p-TBC

| TOPCon  | p-TBC                  |
|---|------------------------|
| Texturing   | Alkaline Polish        |
| BSG Dep.  | LPCVD i-poly           |
| Laser induce B drive                              | P diffusion            |
| Oxidation   | Laser pattern          |
| Alkaline polish                                   | Texturing by PSG mask? |
| PECVD polySi Dep.                                 |                        |
| Annealing   |                        |
| RCA   | AlO <sub>x</sub>       |
| Al <sub>2</sub> O <sub>3</sub> / SiN <sub>x</sub> | SiN <sub>x</sub>       |
| Screen printing                                   | Screen printing        |
| Sinter + Intense light assisted refire            | Sinter & Dark Anneal   |
| Test & sorting                                    | Test & sorting         |

- TOPCon cells in mass production have achieved open circuit voltage ( $V_{oc}$ ) of 730 mV, owing to the successful implementation of boron diffusion, laser induced boron doping, LP/PE polySi deposition and intense light assisted refire.
- p-TBC loses > 1% efficiency due to recombination caused by Al-BSF.
- No room for further improvement on passivation quality.
- Only if upgrade the cell to bi-polar polySi passivated contact.
- Eventually TOPCon and p-TBC have achieved identical  $V_{oc}$  (730mV) and module power (585W@M10-72module)

# Typical IV data of p-TBC (M10)

| Batch (2023.9.11) | Quantity (PCS) | Eff (%) | Max Eff (%) | Voc (V) | Isc (A) | Jsc (A/cm <sup>2</sup> ) | FF (%) | Rsh (Ω) | Rs (Ω-cm <sup>2</sup> ) | RserLfDf IEC | Irev2 (A) | SunsV <sub>oc</sub> FF (%) | Jo1 (fA/cm <sup>2</sup> ) | Jo2 (nA/cm <sup>2</sup> ) | pFF (%) | Yield (%) |
|-------------------|----------------|---------|-------------|---------|---------|--------------------------|--------|---------|-------------------------|--------------|-----------|----------------------------|---------------------------|---------------------------|---------|-----------|
| RUN247            | 3362           | 25.24   | 25.62       | 0.7297  | 14.031* | 42.14*                   | 82.11  | 1660    | 0.56                    | 0.0017       | 0.75      | 84.58                      | 19.6                      | -0.1                      | 84.75   | /         |

\* Jsc Internally measured, defined and tracked from module power according TUV certification.

\* A

| Batch (2023.9.11) | Max hot spot Temp Diff. (°C) | Quantity | Ratio | Bias |
|-------------------|------------------------------|----------|-------|------|
| 1                 | <5                           | 3387     | 99.7% | -13V |
| 2                 | 5~7                          | 4        | 0.1%  |      |
| 3                 | 7~10                         | 3        | 0.1%  |      |
| 4                 | >10                          | 2        | 0.1%  |      |

| Batch (2023.9.11) | Binning by Irev2 | Quantity | Ratio |
|-------------------|------------------|----------|-------|
| 1                 | <0.5A            | 2013     | 59.0% |
| 2                 | 0.5-1A           | 479      | 14.1% |
| 3                 | 1-3A             | 794      | 23.3% |
| 4                 | >3A              | 123      | 3.6%  |

# Hot spot on p-TBC cells

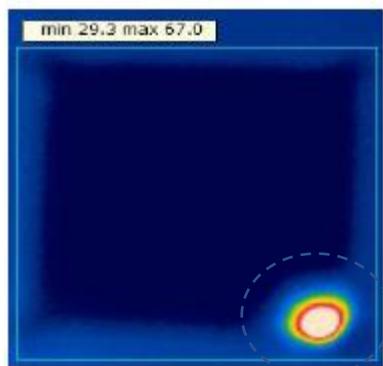
## Hot spot is the **red-line** for module reliability

- For p-TBC cells with low leakage current, the hot spot temperature and knee-point current of the module is similar to those of a PERC module with the same configuration.
- The shading fraction of individual cell when bypass diodes activated are higher than shading fraction of PERC modules.

| Purpose   | Irev2  | Efficiency loss due to hot spot | Hot spot temperature (°C) | Average diode knee point current (A) | Shading Fraction individual cell when bypass diodes activated |
|---|--------|---------------------------------|---------------------------|--------------------------------------|---|
| Investigating hot spot effect under different leakage current (182-72 module) | < 0.5A | 0.16%/-0.4%                     | 153.9                     | 8.41                                 | 30%   |
|   | 0.5-1A | -1.32%                          | 157.4                     | 8.86                                 | 48%   |
|   | 1-3A   | -0.88%                          | 159.0                     | 9.27                                 | 55%   |
|   | > 3A   | -0.53%/-0.65%                   | 157.1                     | 7.07                                 | 20%   |
| PERC modules as reference (182-72 module)                                     | <0.5A  | N.A.                            | 155.8                     | 6.96                                 | 8%  |

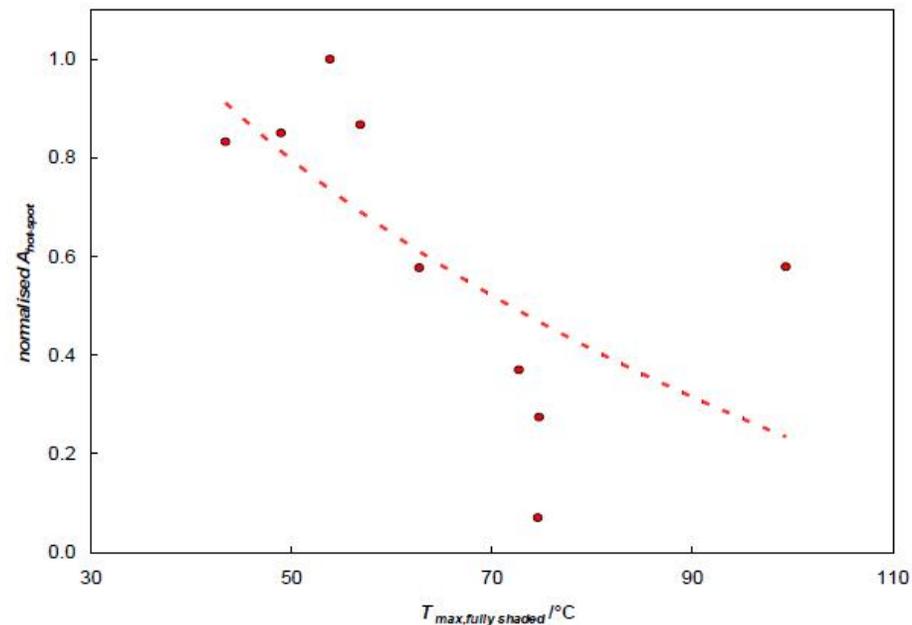
# Hot spot temperature increases linearly with leakage current density

$$J_{leakage} = \frac{I_{leakage}}{A_{hot-spot}}$$



$A_{hot-spot}$

$J_{leakage}$ : leakage current density,  $I_{leakage}$ : leakage current,  $A_{hot-spot}$ : total area of current leakage region



**Figure 6:** Correlation between the hot spot size and the hot spot temperature.

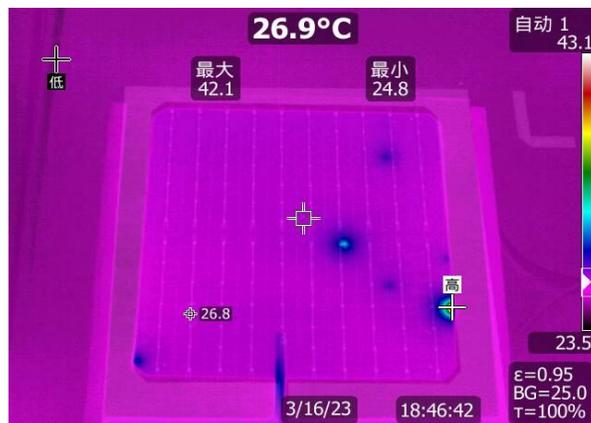
- Hot spot temperature increases linearly with leakage current density. The higher  $J_{leakage}$  gets, the higher the hot spot temperature becomes

# Leakage current densities of PERC and p-TBC cells

## Comparison of single cells:

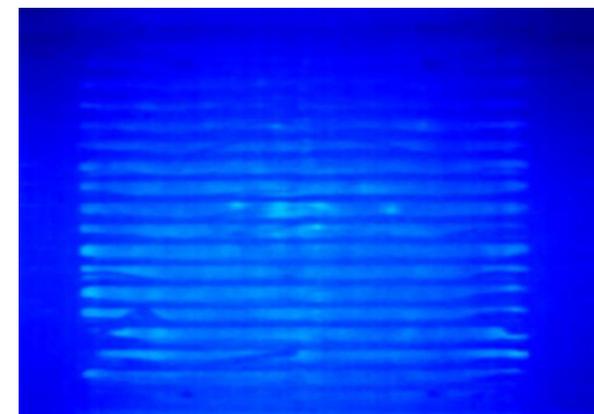
- At 182 mm cell size, **-13V bias**, the p-TBC sample has a leakage current ( $I_{leakage}$ ) of 2A while PERC samples has an  $I_{leakage}$  of 0.18A:
- When leakage current is at 2A, the p-TBC cell has lower  $J_{leakage}$  (leakage current density) than that of the PERC cell; Despite of this, p-TBC cells still have limited tolerance for leakage current.

When leakage current is greater than 10A, an alternative solution for **HOTSPOT** is required.



PERC cell

$T_{MAX}=42.1^{\circ}C$   
 $I_{leakage}=0.18A$   
 $A_{hot-spot}=60mm^2$   
 $J_{leakage}=0.003A/mm^2$



p-TBC cell

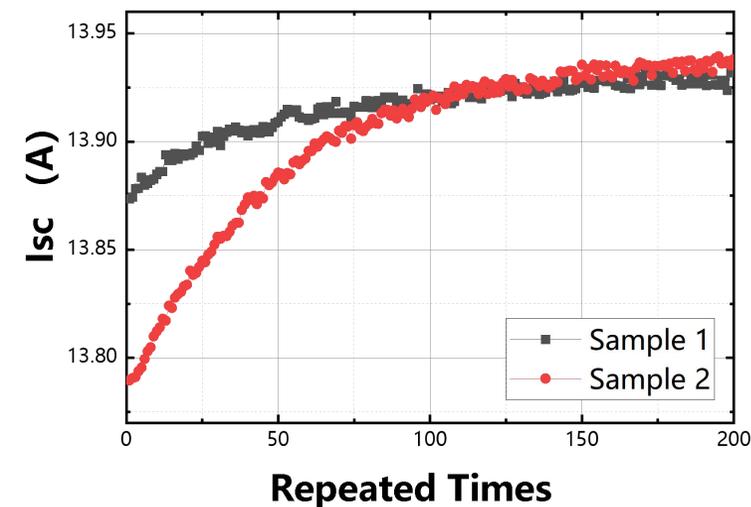
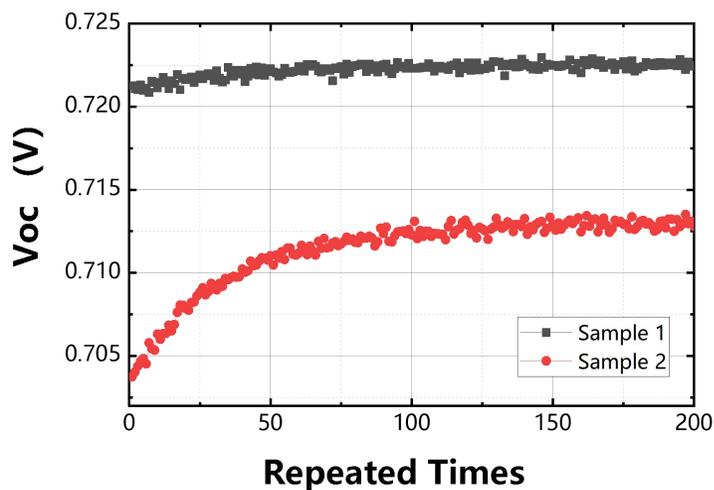
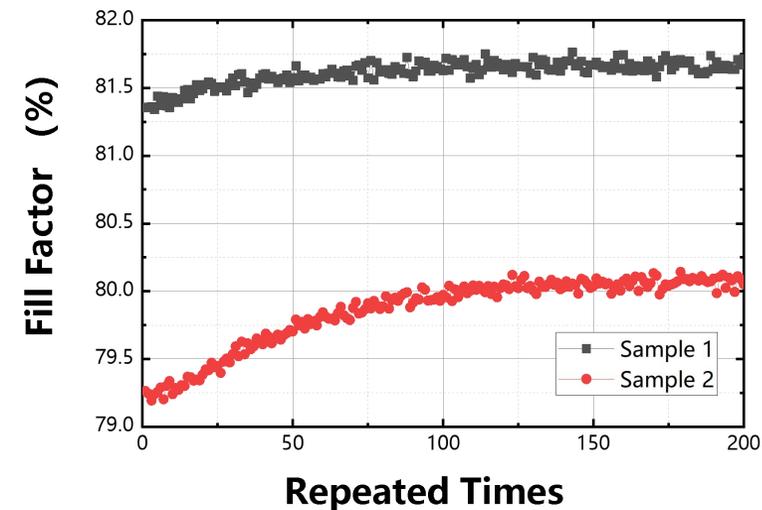
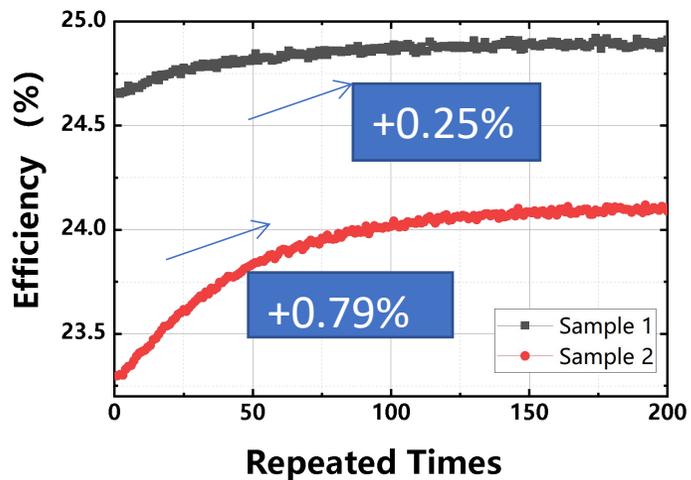
$T_{MAX}=30.22^{\circ}C$   
 $I_{leakage}=2A$   
 $A_{hot-spot}=3926mm^2$   
 $J_{leakage}=0.0005A/mm^2$

- The leakage current of TBC cells is uniform across the entire cell.
- Mass produced TBC cells have larger leakage current than mass produced PERC cells

# Instability of p-TBC cell efficiency

--Repeated I-V tests

Under exposure to flashing during repeated I-V tests, p-TBC cell efficiency temporarily increases until a plateau due to the limit by passivation



Equipment manufacturer: Halm  
 Luminance: 1000W/m<sup>2</sup>  
 Interval between tests: 2s

# Instability of p-TBC cell efficiency

Cell efficiencies increase after exposure to repeated flashing (200 times), but drops when stored in dark overnight

Possible causes:

FeGa decomposition in p-type silicon wafers<sup>①②</sup>; passivation quality of AlO<sub>x</sub> improves when exposed to repeated flashing<sup>③</sup>

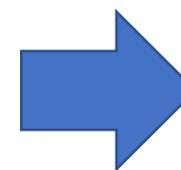
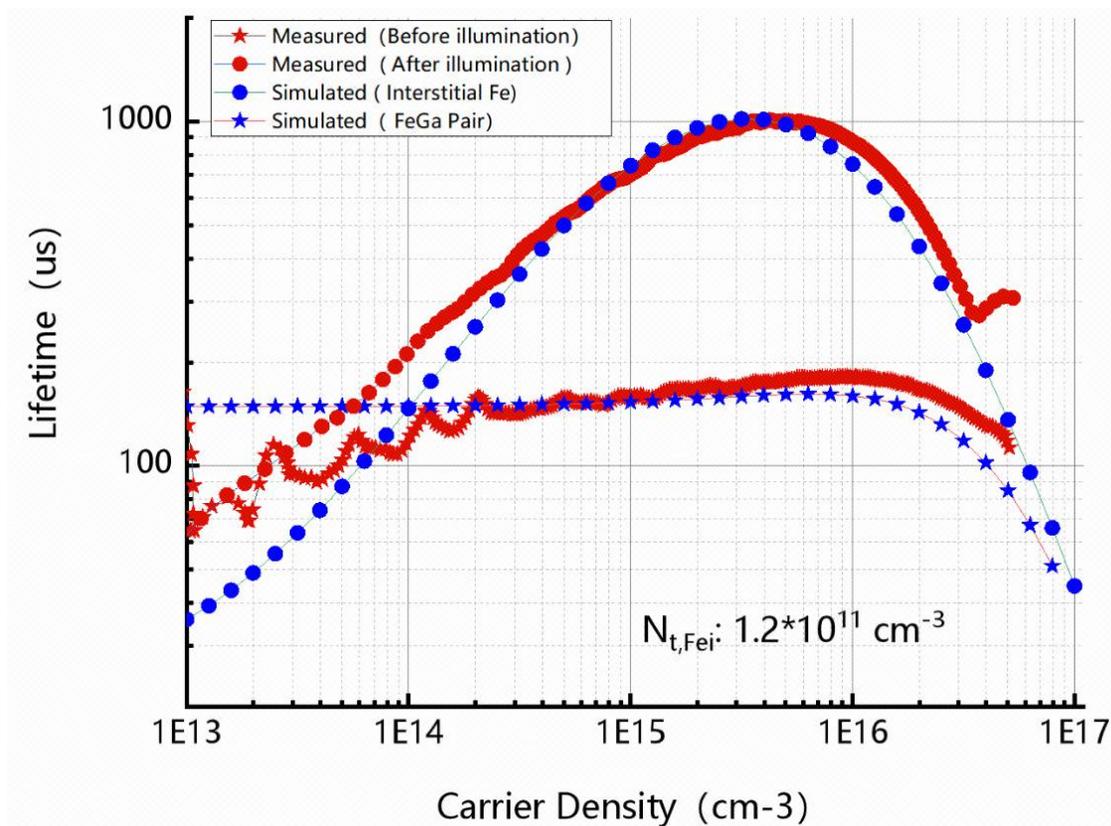
| Efficiency Category | Condition         | Eff (%) | Voc (V) | Isc (A) | FF (%) | PFF (%) | Rs (Ω-cm <sup>2</sup> ) |
|---------------------|-------------------|---------|---------|---------|--------|---------|-------------------------|
| 24.0%               | Initial           | 24.06   | 0.7242  | 13.934  | 79.41  | 84.23   | 0.83                    |
|                     | Flash 200 times   | 24.50 ↑ | 0.7268  | 13.994  | 80.23  | 84.89   | 0.74                    |
|                     | Stored for 12 hrs | 24.11 — | 0.7251  | 13.931  | 79.48  | 84.18   | 0.80                    |
|                     | ΔEff              | 0.44    | 0.0025  | 0.060   | 0.82   | 0.66    | -0.09                   |
| 24.5%               | Initial           | 24.52   | 0.7247  | 13.968  | 80.68  | 84.94   | 0.70                    |
|                     | Flash 200 times   | 24.99 ↑ | 0.7261  | 14.021  | 81.74  | 85.74   | 0.62                    |
|                     | Stored for 12 hrs | 24.55 — | 0.7248  | 13.965  | 80.77  | 84.94   | 0.69                    |
|                     | ΔEff              | 0.46    | 0.0014  | 0.053   | 1.05   | 0.80    | -0.08                   |
| 25.0%               | Initial           | 25.02   | 0.7289  | 14.050  | 81.34  | 85.71   | 0.67                    |
|                     | Flash 200 times   | 25.25 ↑ | 0.7295  | 14.076  | 81.86  | 86.15   | 0.65                    |
|                     | Stored for 12 hrs | 25.05 — | 0.7294  | 14.047  | 81.40  | 85.78   | 0.65                    |
|                     | ΔEff              | 0.23    | 0.0006  | 0.026   | 0.52   | 0.43    | -0.02                   |

① Marwan Dhamrin PhD Thesis, Fabrication and Evaluation of Ga-doped Multicrystalline Silicon Wafers and Solar Cells

② Nærland T U, Bernardini S, Haug H, et al. On the recombination centers of iron-gallium pairs in Ga-doped silicon[J]. Journal of Applied Physics, 2017, 122(8): 085703.

# FeGa affected minority carrier lifetime fitting

|      | Dopant level (eV) | Et-Ei | Electron capture cross section $\sigma_n$ (cm <sup>2</sup> ) | Hole capture cross section $\sigma_p$ (cm <sup>2</sup> ) | Ratio of E/H capture cross section $\sigma_n/\sigma_p$ | References |
|------|-------------------|-------|--|--|--|------------|
| Fei  | Ev+0.38           | -0.18 | 4.00E-14   | 7.00E-17   | 571.4  | Istratov   |
| FeGa | Ev+0.2            | -0.36 | 1.20E-14   | 6.00E-15   | 2.000  | Narland    |

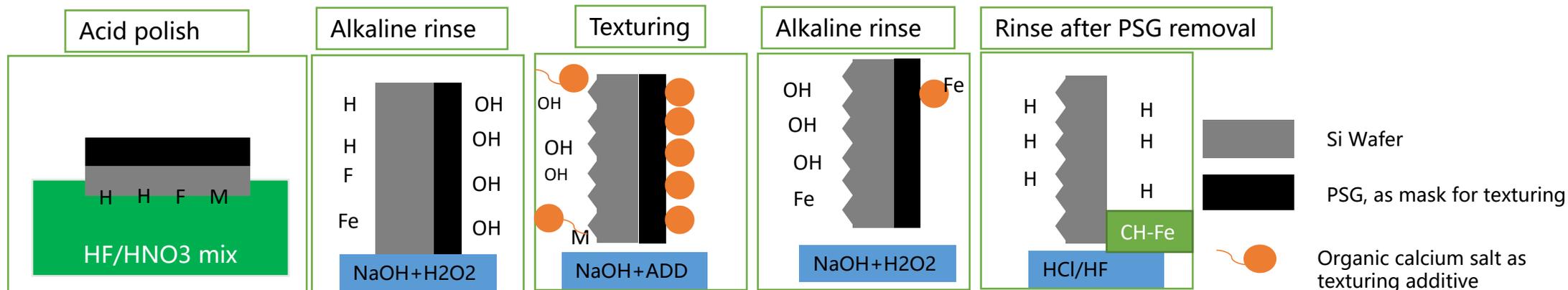


- Estimated FeGa concentration:  $1.0 \sim 1.3 \times 10^{11} \text{ cm}^{-3}$ ;

# Possible Origins of FeGa in Cells

Origin 1: metal adsorption during the last wet chemical process (1~10ppb)

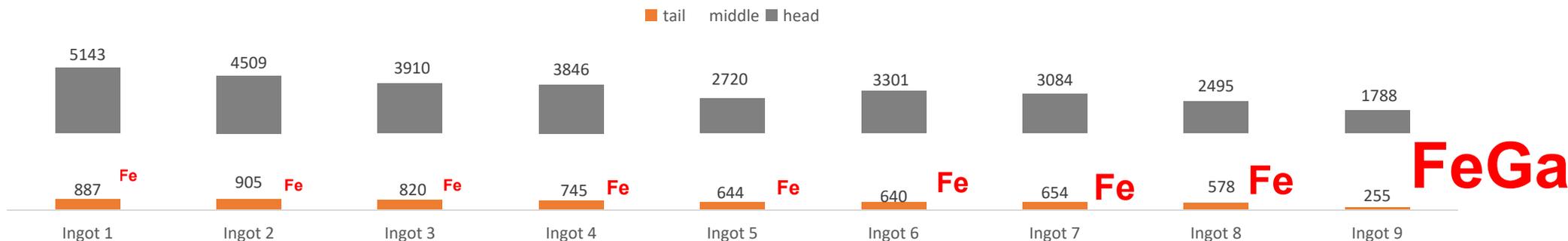
Iron originated from acid should be strictly controled



Origin 2: Fe segregation in silicon ingots, which forms percipitates that dissolves as Fe reserivor during high temperature process in cell fabrication

Iron-Gallium pairs are unavoidable since p/Ga doped ingot pulling feedstock comsuption is over 4000 kg per crucible

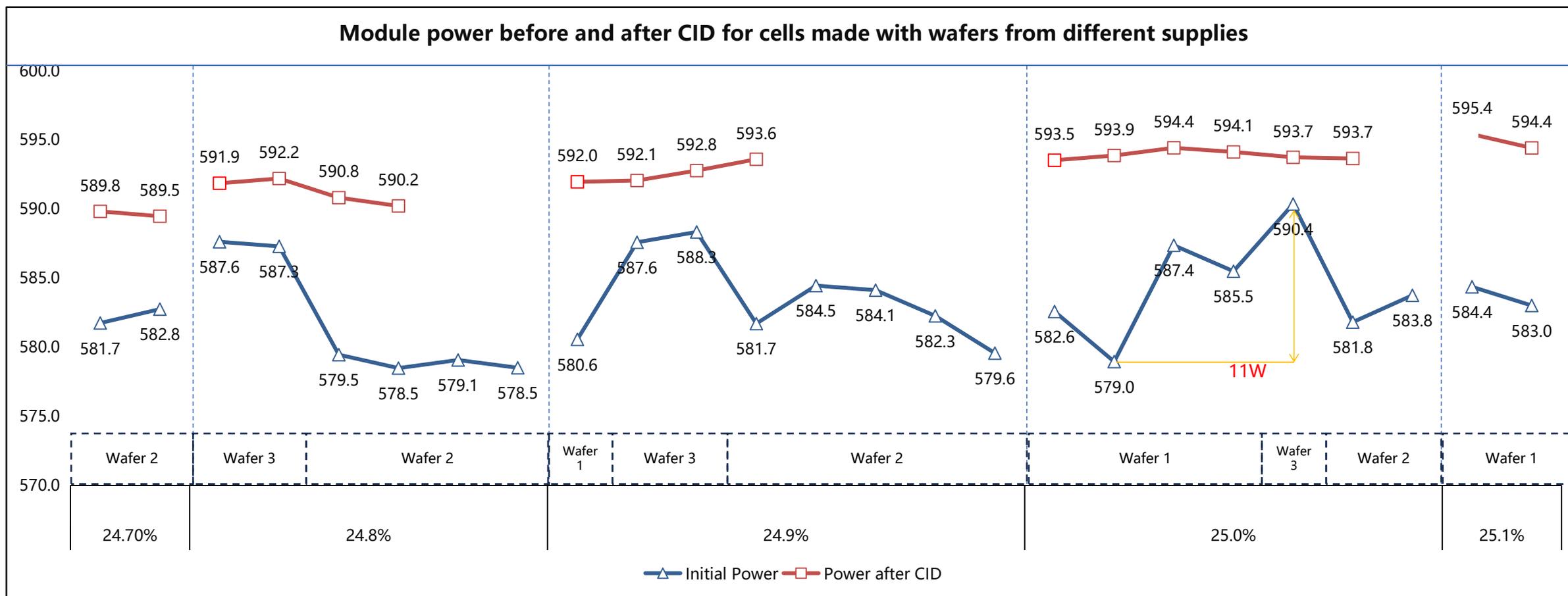
Minority Carrier Lifetime Silicon Ingots for p-TBC cells



# Power instability of p-TBC module

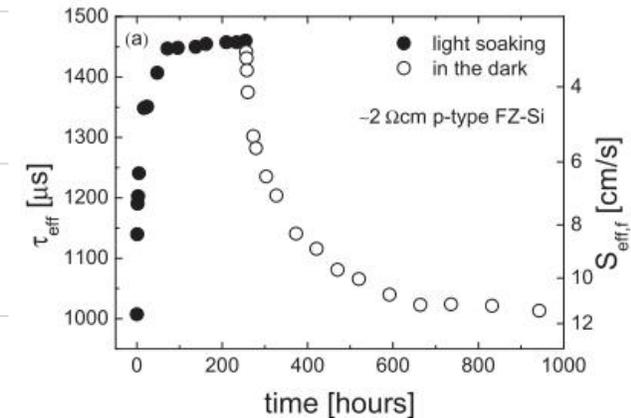
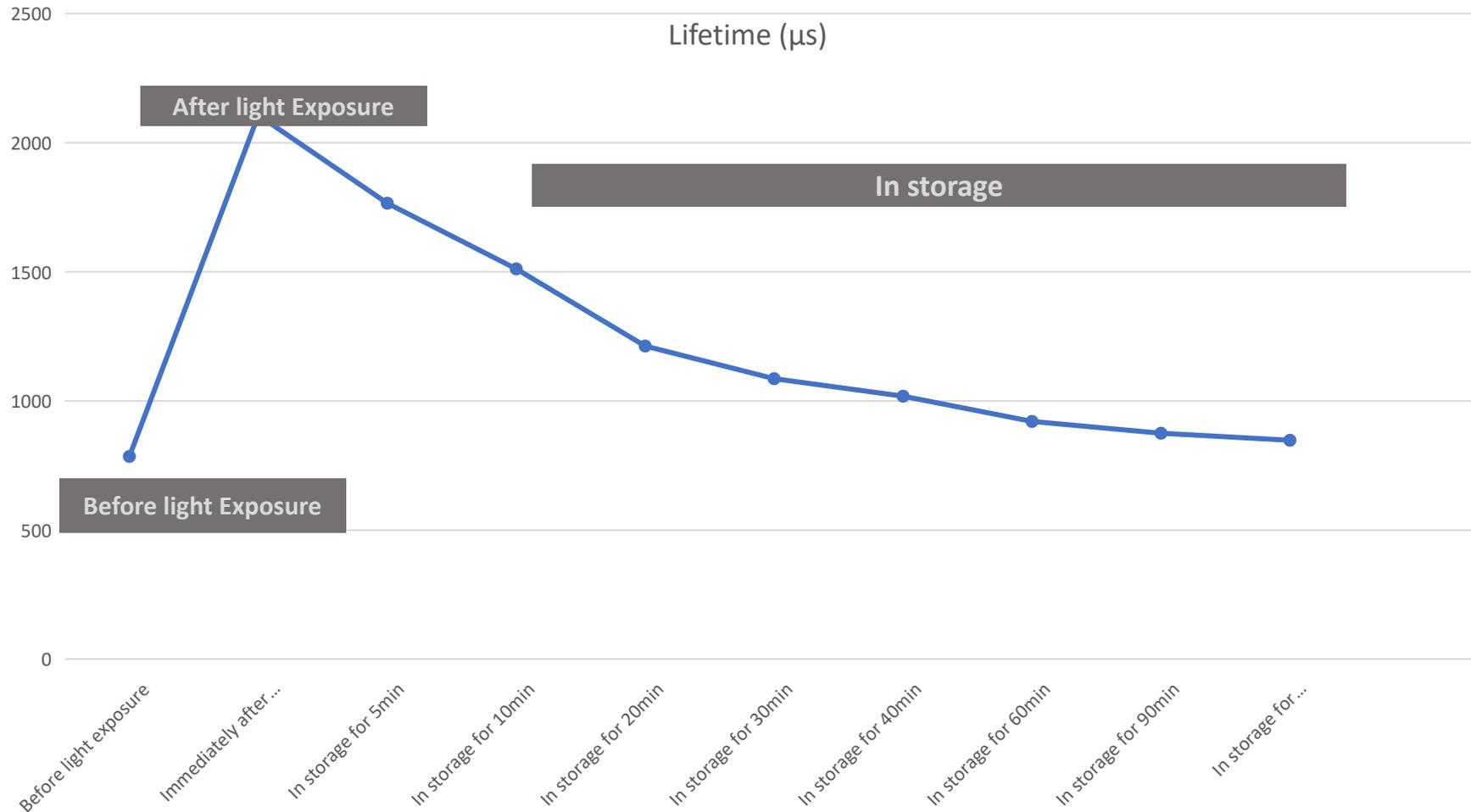
Photo-injection can cause temporary efficiency increase for p-TBC cells, so should current injection

- Current injection can increase module power by 4~11W
- Before current injection, it is hard to predict module power by cell efficiency, due to discrepancies as large as 11W. After current injection, a trend can be established to some extent



# Instability of AlO<sub>x</sub> passivated p-type wafer surface

- P-type + AlO<sub>x</sub> passivated wafer: Carrier lifetime before and after light exposure, as well as in storage (@ 10<sup>15</sup>cm<sup>-3</sup>)





# Influence of AlO<sub>x</sub> passivation instability on PBC cells

## Quokka3 Simulation

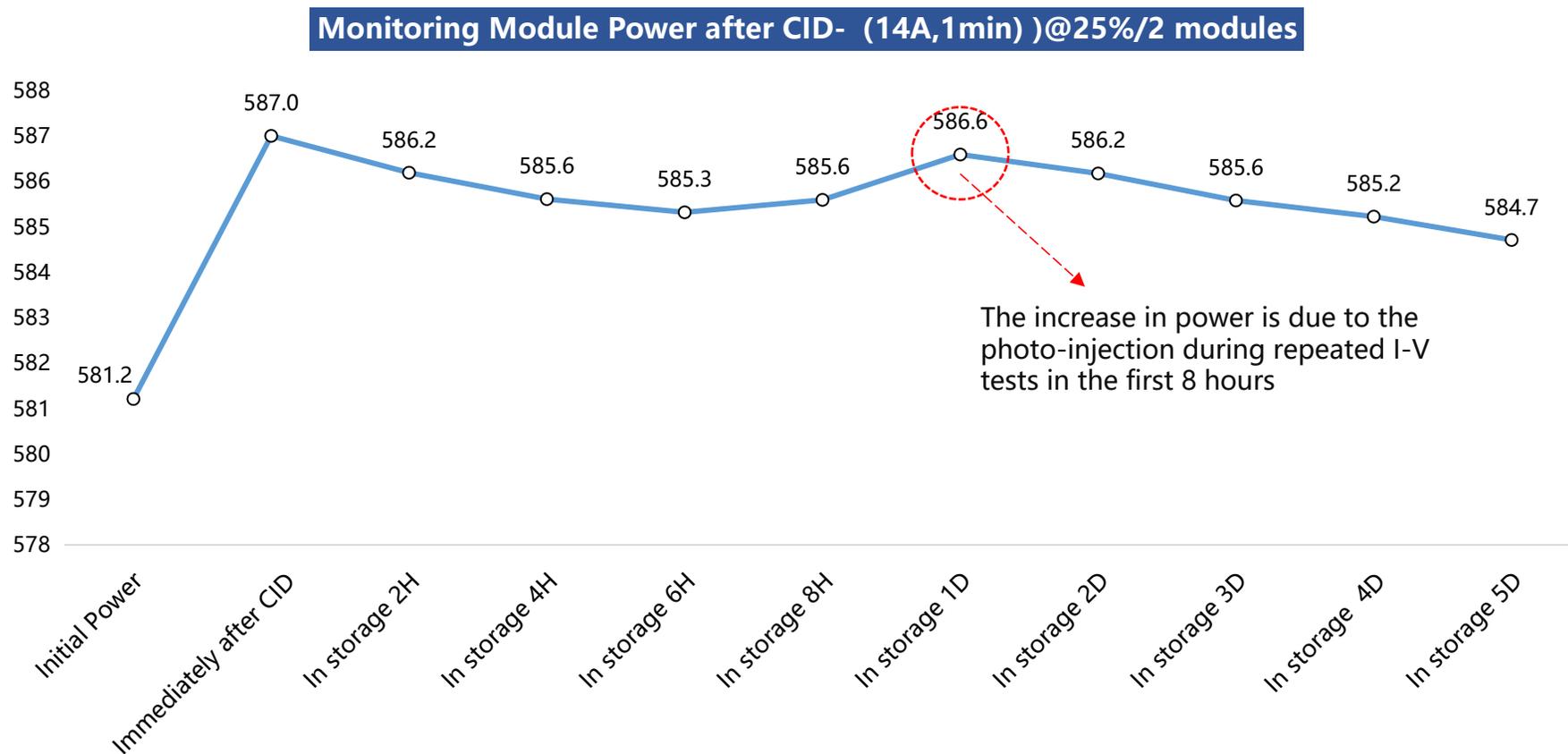


- The evolution from BSF cell to PERC cell is primarily the result of the implementation of AlO<sub>x</sub> passivation on p-type Si wafers. Due to its high density of fixed negative charges ( $Q_f > 10^{12}/\text{cm}^3$ ), AlO<sub>x</sub> can effectively repel electrons, the minority carrier in p-type silicon wafers, thereby reducing surface recombination velocity
- According to literature, exposure to light, especially UV light, may lead to an increase in  $Q_f$  for AlO<sub>x</sub>, which results in enhanced passivation quality. This effect is demonstrated in the following table:

Influence of Fixed Charge density of AlO<sub>x</sub> on PBC cells

| Fixed Charge/cm-3 | Voc/V  | Jsc/mA/cm2 | FF/%  | Eff/%        | pFF/% |
|-------------------|--------|------------|-------|--------------|-------|
| -1E+12            | 0.7248 | 41.35      | 82.14 | <b>24.62</b> | 85.40 |
| -2E+12            | 0.7289 | 41.41      | 82.65 | <b>24.94</b> | 85.63 |
| -3E+12            | 0.7301 | 41.42      | 82.83 | <b>25.05</b> | 85.71 |
| -4E+12            | 0.7306 | 41.42      | 82.93 | <b>25.10</b> | 85.75 |
| -5E+12            | 0.7310 | 41.42      | 82.99 | <b>25.13</b> | 85.77 |

# Monitoring PBC module power after CID



- Current injection results in 5.8W power gain for modules, but it gradually decreases in storage

# Summary

- It is possible to mass produce p-TBC cells with 25% efficiency, as well as p-TBC modules with 585W power
- p-TBC cells have relatively high tolerance for leakage current. No abnormality is observed when leakage current is under 3A. Generally, **p-TBC has 10 times better tolerance for leakage current than that of PERC. Although further investigation is required if leakage current becomes higher.**
- p-TBC cells under **repeated flashing**, as well as p-TBC modules after **CID**, will exhibit **temporary efficiency gain**
  - A possible cause could be that the FeGa in Ga-doped wafers would decompose under light exposure or under current injection. And such decomposition would enhance cell efficiency temporarily, which reverts when external stimulant (photo- or current injection) is removed
  - Another possible cause is the temporary improvement of AlOx passivation under external stimulant
- There are **irregularities in cell efficiencies**, which is **caused by the differences in wafers from various manufacturers**. Current injection can alleviate such irregularity but
- **CID induced Module power** is not stable
- The stability of photo-induced power gain in modules needs long-term monitoring when they are fielded.

Thanks!

